

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Aaron PARTRIDGE et al.
 Serial No. : 10/713,172
 Filing Date : November 14, 2003
 For : CRACK AND RESIDUE FREE CONFORMAL
 DEPOSITED SILICON OXIDE WITH
 PREDICTABLE AND UNIFORM ETCHING
 CHARACTERISTICS
 Examiner : Francis P. Smith
 Group Art Unit : 1792
 Confirmation No. : 9823
Customer No. : 26646

Mail Stop AF
 Commissioner for Patents
 P.O. Box 1450
 Alexandria VA 22313-1450

I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on February 17, 2009.

Signature: /Aaron Grunberger/
 Aaron Grunberger (Reg. No. 59,210)

TRANSMITTAL FOR AMENDMENT AFTER FINAL OFFICE ACTION

SIR:

Transmitted herewith for filing in the above-identified patent application is an Amendment in response to the Office Action of November 7, 2008.

Applicants respectfully petition for one-month extension of time to respond to the Office Action of November 7, 2008, for which a three-month response period expired on February 7, 2009. The extended period for response expires on March 7, 2009. The \$130 extension of time fee is being paid by credit card.

The Commissioner is also authorized to charge payment of any additional fees or to credit any overpayment, to the Deposit Account of Kenyon & Kenyon LLP, Deposit Account No. 11-0600.

Respectfully submitted,

/Aaron Grunberger/

Dated: February 17, 2009

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